

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Customer No. 026418
Docket No. JG-SU-5207/500577.20063
Applicant(s): Daisuke Wakabayashi et al. Examiner: Felisa Carla Hiteshew
Application No.: 10/521,035 Group Art Unit: 1722
Filed: August 2, 2005 Confirmation No.: 6571
For: **METHOD FOR MANUFACTURING SILICON SINGLE CRYSTAL**

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

In response to the office action mailed June 23, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Amendments to the Abstract begin on page 11 of this paper.

Remarks begin on page 12 of this paper.

I hereby certify that this correspondence is being electronically filed with the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on September 25, 2006.

Jules E. Goldberg